

## 6th EUV-FEL Workshop



Contribution ID: 7

Type: **not specified**

### **Invited speaker (4) Demonstration of Proof-of-Concept of EUV and Beyond EUV FELs for Future Lithography**

*Tuesday, 18 January 2022 16:20 (30 minutes)*

**Presenter:** NORIO NAKAMURA (KEK) (KEK)